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GODDARD SPACE FLIGHT CENTER

Test Lab Report Summary

Project: Report Number: Q10175DPA **SWIFT** Part Type: Microcircuit System: **BAT** Part Number: TMP36GRT Initiated Date: 05/01/2001 Date Code: 9922 Report Date: 10/25/2001

Manufacturer:Analog DevicesInvestigator:C. Greenwell (562)Generic Number:TMP36Requester:B. Meinhold (562)

Purchase Spec: Commercial Approval / Date:

Step 1: INCOMING INSPECTION

<u>Test</u>	Quantity	<u>Passed</u>	<u>Failed</u>
External Visual	N/A	N/A	N/A
PIND Condition A	N/A	N/A	N/A

Step 2: DESTRUCTIVE PHYSICAL ANALYSIS

Destructive Physical Analysis (DPA) was conducted per GSFC document "Plastic Encapsulated Microcircuit (PEM) Guidelines for Screening and Qualification for Space Applications", except that cross-section was done without dye penetrant and glassivation integrity testing was not performed.

17. SEM inspection revealed unacceptable metallization step coverage on SN's 03, 04 and 05 (see Figures 11 – 13). Some of the contacts were slightly misaligned which allowed for a quasi cross-sectional type view of these features. From these views it is estimated that the reduction from nominal metallization thickness is greater than 70%. This condition is cause for rejection per MIL-STD-883, Method 3.7.2. These devices have metal stripe widths of 2 μm.

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Part No: TMP36GRT Microcircuit Part Type: Manufacturer: Date Code: **Analog Devices** 9922 Summary of Analysis: Serial Number 01 02 05 03 04 External Examination Markings - legibility and correctness Α Α Α Α Α 2. Integrity of package seals N/A N/A N/A N/A N/A 3. Condition of external leads and plating _____ Α Α Α Α Α 4. Overall package condition Α Α A Α A Radiographic Examination 5. Die bonding material and die alignment Α Α Α Α Α 6. Package seal integrity _____ N/A N/A N/A N/A N/A 7. Presence of foreign material Α Α Α A A 8. Lead dress (if revealed) Α Α Α A A Acoustic Microscopy Inspection 9. Condition of material interfaces (delaminations) _____ A Α Α A A 10. Condition of molding material (voids, cracks) Α Α Α Α A *Internal Examination* (including cross-section) 11. Presence of foreign material Α Α Α Α Α 12. Mechanical condition of die A Α A A A 13. Wire bonds and lead dress N/P N/P Α A A 14. Die bonding material N/P N/P Α A A 15. Condition of die surface N/P N/P Α Α Α 16. Condition of metallization _____ N/P N/P Α A Α 17. SEM Examination ______ N/P N/P IJ* IJ* U* **Bond Strength** 18. Strength N/P N/P Α A Α 19. Metallization adherence _____ N/P N/P A Α A Die Bond Strength

SN's 01 and 02 subjected to cross-sectional examination.

N/P

N/P

N/P

N/P

N/P

20. Strength

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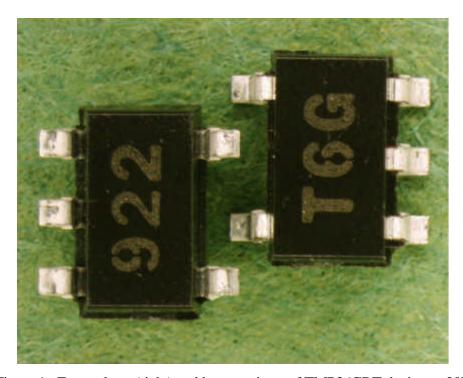


Figure 1. External top (right) and bottom views of TMP36GRT devices. 20X

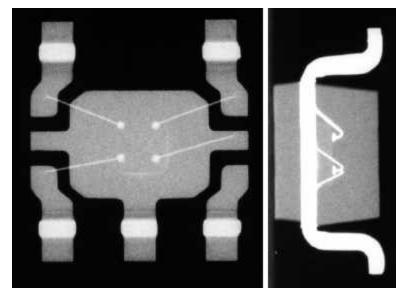


Figure 2. Top and side view radiographic images. 12X

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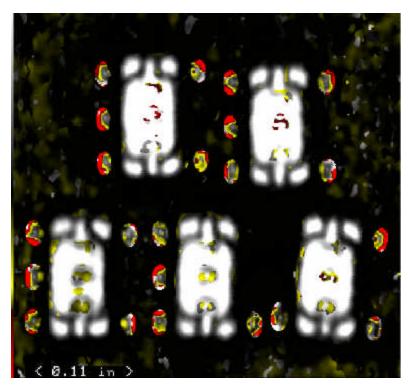


Figure 3. Top view C-SAM images of all five samples. The non-white areas of the die paddle are due to the part markings on the external surface.

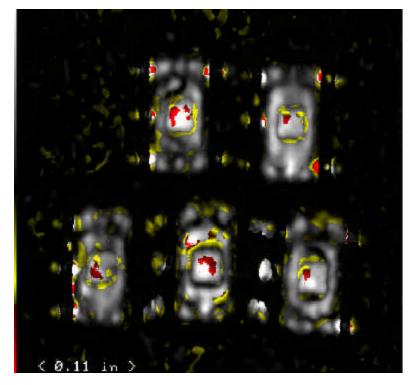


Figure 4. Bottom view C-SAM images.

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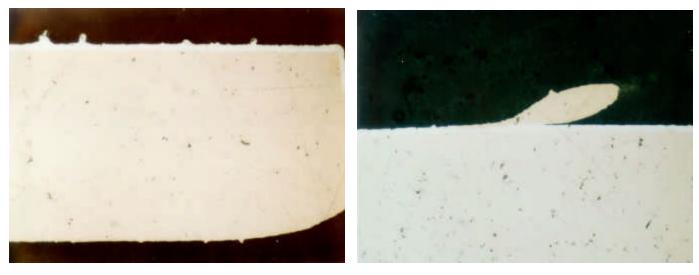


Figure 5. Cross-sectional images of SN's 1 (left) and 2. No delaminations were observed at three randomly sectioned planes within these samples. Both images - 400X

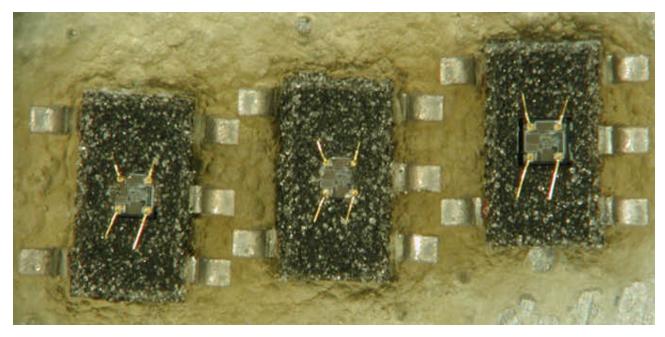
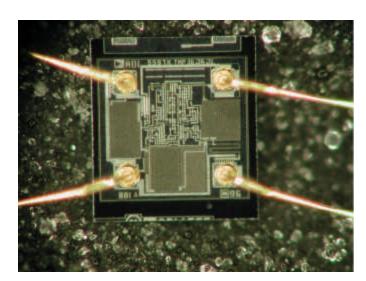


Figure 6. Three samples (SN's 03, 04 and 05; right to left) deprocessed and ready for internal examination. They are fixed with epoxy to an SEM mount.

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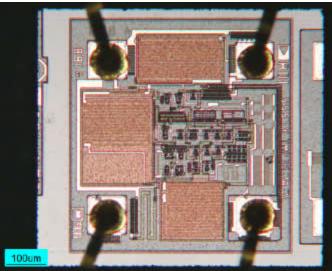


Figure 7. Optical macrograph images of SN 03.

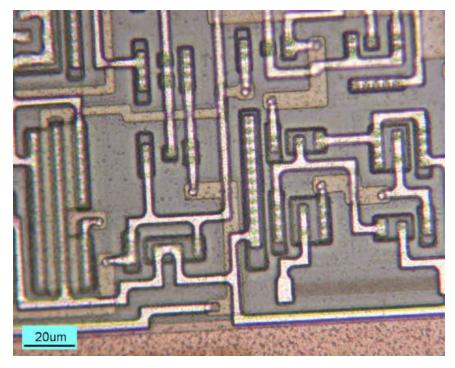


Figure 8. Optical micrograph image shows typical die features on SN 03.

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Appended Photographs:

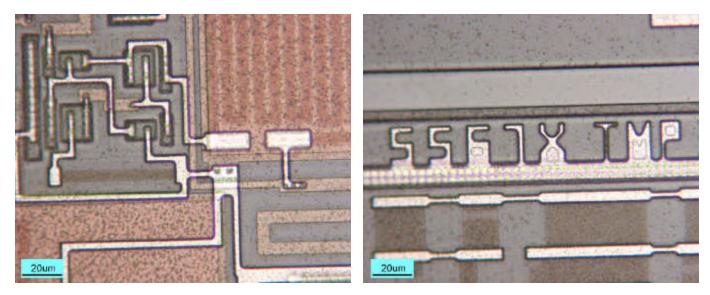


Figure 9. Optical images show features on SN 04.

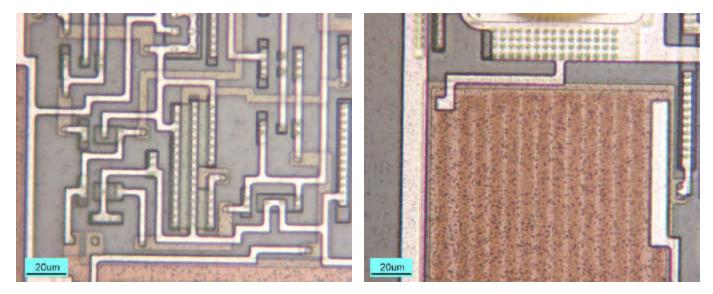


Figure 10. Optical images of features on SN 05.

These devices are difficult to inspect because of the relatively large topographical features on the dice and the grainy appearance of the passivation/glassivation layers.

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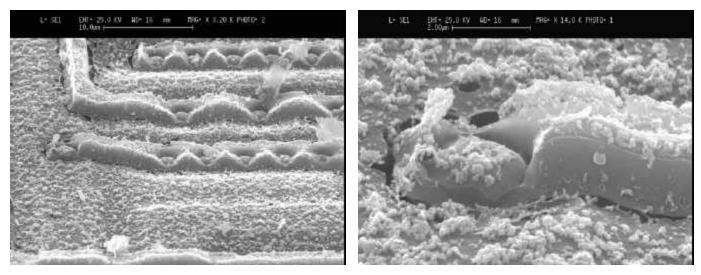


Figure 11. SEM micrograph images show rejectable step coverage features on SN 03 die. The right side image shows the metallization thickness reduced greater than 70% at this step. The left image shows the large topography variation that the metallization is deposited on.

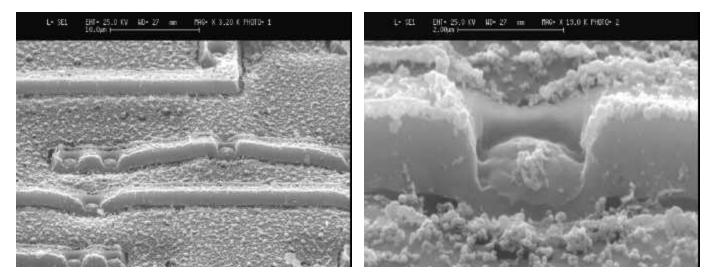
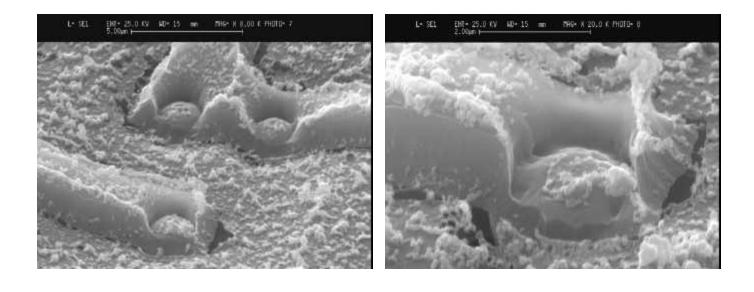


Figure 12. Similar features present on SN 04. Some of the debris present in these images is likely to be deprocessing artifact. It is not believed that the grainy surface feature is artifact; however, it is not known what this is.

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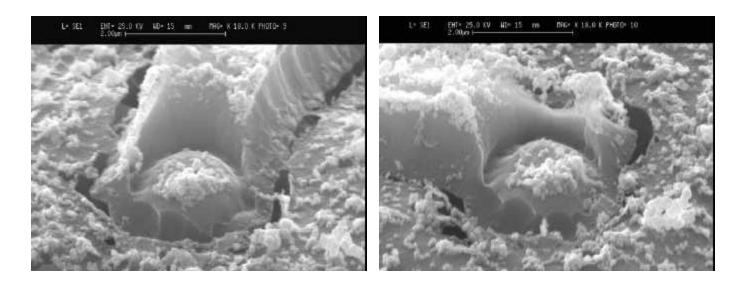


Figure 13. SEM images of similar features on SN 05.